

Docket No.: 55071-329

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
: Douglas VAN DEN BROEKE, et al. :
Serial No.: : Group Art Unit:
: Filed: January 14, 2004 : Examiner:
: For: METHOD AND APPARATUS FOR PROVIDING OPTICAL PROXIMITY
FEATURES TO A RETICLE PATTERN FOR DEEP SUB-WAVELENGTH OPTICAL
LITHOGRAPHY

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows:

IN THE SPECIFICATION: